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BY:

DATE:

Justin L. Hewell
March 27, 2003

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Patent Application of
Kiyoshi Taguchi *et al.*

: Group Art Unit: 1764

Conf. No.: 9338

Appln. No.: 09/357,507

: Examiner: Jennifer A. Leung

Filed: July 20, 1999

For: Hydrogen Purifying Apparatus

: Attorney Docket

: No. 10059-286

: (P20931-01)

AMENDMENT

This is in response to the Office Action mailed November 27, 2002 (Paper No. 16) in the above-identified action. This response is being timely filed in view of the simultaneous filing of a on-month Petition for Extension of Time on March 27, 2003.

Please amend the application, without prejudice, as follows:

In the Specification:

Please amend the ABSTRACT OF THE DISCLOSURE section on page 53 of the specification and replace it with the ABSTRACT OF THE DISCLOSURE section shown in clean form below and having all the underlined additions and all bracketed deletions as shown in the attached Marked-Up Version of the Specification as follows:

-ABSTRACT OF THE DISCLOSURE

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